

<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> <small>(Use several sheets if necessary)</small>				Document Number (Optional)	Application Number	
				TSMC-00-488	10/791,014	
				Applicant Chung-Shi Liu et al.		
				Filing Date 03/02/04	Group Art Unit	
<b>U. S. PATENT DOCUMENTS</b>						
EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	SEARCH DATE IF APPROPRIATE
PE	6008120	12/28/99	Lee	438	634	12/1/98
PE	6103601	8/15/00	Lee et al.	438	513	6/10/99
PE	6121164	9/19/00	Yieh et al.	438	790	10/24/97
PE	6130157	10/19/00	Liu et al.	438	669	7/16/99
PE	6136680	10/24/00	Lai et al.	438	597	1/21/00
PE	6150272	11/21/00	Liu et al.	438	692	11/16/98
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO
<b>OTHER DOCUMENTS</b> (including Author, Title, Date, Page No., Etc.)						
<b>EXAMINER</b> <i>Peter Koral</i>			<b>DATE CONSIDERED</b> <i>8/27/05</i>			

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.